Attorney's Docket No.: 10417-092002 / S21-165933M/KIK

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Motoyuki Tsuihij et al.

Art Unit : Unknown

Filed

: February 18, 2004

Examiner: Unknown

Title

: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **INFORMATION DISCLOSURE STATEMENT**

Applicant submits the references listed on the attached form PTO-1449.

Under 35 USC §120, this application relies on the earlier filing date of application serial number 09/931,554, filed on August 16, 2001. All references listed on form PTO-1449 were submitted to and/or cited by the Office in the prior application and, therefore, copies are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

2/18/04

Reg. No. 38,388

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10417-092002	Application No.
Information Disclosure Statement by Applicant		Applicant Motoyuki Tsuihij et al.	
(Use several sh (37 CFR §1.98(b))	eets if necessary)	Filing Date February 18, 2004	Group Art Unit

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,299,513	10/2001	Tsuihiji et al.			
	AB	5,772,900	06/1998	Yorita et al.			
	AC	5,755,614	05/1998	Adams et al.			
	AD	5,240,656	08/1993	Scheeres			
	AE	5,102,594	04/1992	Burlet et al.			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or				lation
Initial	ID ID	Number	Date	Patent Office	Class	Subclass	Yes:	No
	AL	11-19672	01/26/1999	Japan				
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)				
Examiner Initial	Desig. ID	Document		
	AQ	Patent Abstracts of Japan; 11-019672; 26/01/1999		
	AR			
	AS			
	AT			

Examiner Signature	Date Considered
EVAMINED. International Design of the Control of th	<del> </del>
EXAMINER: Initials citation considered. Draw line through citation if not next communication to applicant	in conformance and not considered. Include copy of this form with